




Sheet 1 of 1 (11/10/03)

Form PTO-1449		ATTY. DOCKET NO. 0104-0279P		APPLICATION NO. 09/623,195				
INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)				APPLICANT Torbjorn SANDSTROM				
				FILING DATE August 29, 2000				
GROUP 2873								
U.S. PATENT DOCUMENTS								
EXAMINER INITIAL	DOCUMENT NUMBER	Kind	DATE	NAME	CLASS SUB CLASS	FILING DATE IF APPROPRIATE		
W.C.	US 4 566 935		1986-01-28	Hornbeck	438 29			
	US 5 296 891		1994-03-22	Vogt et al.	355 67			
	US 5 504 504		1996-04-02	Markandey et al.	245 214			
	US 5 508 841		1996-04-16	Lin et al.	259 318			
	US 5 539 567		1996-07-23	Lin et al.	359 281			
	US 5 539 568		1996-07-23	Lin et al.	359 285			
	US 5 835 256		1998-11-10	Huibers	359 291			
	US 6 060 224		2000-05-09	Sweatt et al.	430 395			
	US 6 285 488		2001-09-04	Sanstrom	359 290			
	US 6 373 619		2002-04-16	Sandstrom	359 298			
	6 428 940		2002-08-06	Sandstrom	430 22			
	6 489 984		2002-12-03	Johnson	347 239			
FOREIGN PATENT DOCUMENTS								
	Office	DOCUMENT NUMBER	Kind	DATE	COUNTRY	CLASS SUB CLASS	TRANSLATION YES NO	
W.C.	WO 93	09469		1993-05-13	WIPO		X	
	EP	0 467 076		1992-01-22	EP		X	
	WO 99	45439		1999-09-10	WIPO		X	
	WO 00	42618		2000-07-20	WIPO		X	
	WO 98	04950		1998-02-05	WIPO		X	
	WO 99	22262		1999-05-06	WIPO		X	
	WO 99	45441		1999-09-10	WIPO		X	
OTHER DOCUMENTS (Include Name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.)								
W.C.	H. KUCK et al., New System for fast submicron laser direct writing, SPIE Vol. 2440, pgs 506-514							
W.C.	P.M. HAGELIN et al., Micromachining and microfabrication technology for adaptive optics, os 9/16/99							
EXAMINER:  DATE CONSIDERED: 1/8/04								
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

0104-0279P

JMS/PCL/cl